

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Masaki NAKANO ) Examiner: Aaron M. Richer  
Application No.: 10/042,231 ) Group Art Unit: 2628  
Filed: January 11, 2002 ) Confirmation No.: 4817  
For: IMAGE QUALITY PROCESSING )  
APPARATUS, METHOD AND )  
RECORDING MEDIUM, )  
INCLUDING MULTISCREEN )  
SYNTHESIS MEANS FOR )  
COMPOSING ONE SCREEN )  
FOR IMAGE ARRANGEMENT )  
OF PLURAL PIECES OF THE )  
IMAGE FOR TRIMMING, )  
ENLARGEMENT AND )  
REDUCTION (AS AMENDED) ) August 17, 2007

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

STATEMENT OF SUBSTANCE OF INTERVIEW

Sir:

Applicant wishes to thank the Examiner for the courtesies extended in granting and conducting on August 15, 2007, a personal interview with Applicant's representative. At the interview, Applicant's representative and the Examiner discussed the outstanding rejections, which are respectfully traversed, and the July 10, 2007 Amendment. Applicant respectfully understands that the Examiner is in tentative agreement that if the 35 U.S.C. § 112, 1<sup>st</sup> paragraph, rejection is overcome, then the 35 U.S.C. § 103 rejection is also overcome. Favorable consideration is earnestly solicited.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address listed below.

Respectfully submitted,

/Daniel S. Glueck/  
Daniel S. Glueck  
Attorney for Applicant  
Registration No. 37,838

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3800  
Facsimile: (212) 218-2200

DSG/mcm